



Applicant: Gosain, Dharam Pal, et al.

Serial No.: 10/645,805

Filed: August 21, 2003

For: METHOD OF PRODUCING
CRYSTALLINE SEMICONDUCTOR
MATERIAL AND METHOD OF
FABRICATING SEMICONDUCTOR
DEVICE

Case No.: 09792909-5657

Examiner: Schillinger, L. M.

Group Art Unit: 2813

Confirmation No. 8039

Certificate of Mailing (37 CFR 1.8(a))

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AMENDMENT B

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Dear Sir:

This amendment is submitted in response to the Final Office Action of November 14, 2005. Applicants respectfully request reconsideration in view of the remarks presented herein.